## Notice of References Cited Application/Control No. 10/720,838 Applicant(s)/Patent Under Reexamination GROS-JEAN ET AL. Examiner B. Chen Art Unit Page 1 of 1

## **U.S. PATENT DOCUMENTS**

| * |    | Document Number<br>Country Code-Number-Kind Code | Date<br>MM-YYYY | Name                  | Classification |
|---|----|--|-----------------|-----------------------|----------------|
| * | Α  | US-6,784,049 B2                                  | 08-2004         | Vaartstra, Brian A.   | 438/240        |
| * | В  | US-6,787,186 B1                                  | 09-2004         | Hintermaier, Frank S. | 427/255.31     |
| * | С  | US-6,616,972 B1                                  | 09-2003         | Senzaki et al.        | 427/255.31     |
| * | D  | US-2005/0163659 A1                               | 07-2005         | Duveneck et al.       | 422/061        |
| * | Ε  | US-6,806,210 B2                                  | 10-2004         | Shiho et al.          | 438/785        |
| * | F  | US-5,271,957 A                                   | 12-1993         | Wernberg et al.       | 427/109        |
|   | G  | US-  |                 |                       |                |
|   | Ι  | US-  |                 |                       |                |
|   | Ι. | US-  |                 |                       |                |
|   | J  | US-  |                 |                       |                |
|   | К  | US-  |                 |                       |                |
|   | L  | US-  |                 |                       |                |
|   | М  | US-  |                 |                       |                |

## FOREIGN PATENT DOCUMENTS

| * |   | Document Number Country Code-Number-Kind Code | Date<br>MM-YYYY | Country | Name | Classification |
|---|---|---|-----------------|---------|------|----------------|
|   | Z |   |                 |         |      |                |
|   | 0 |   |                 |         |      |                |
|   | Р |   |                 |         |      |                |
|   | a |   |                 |         |      |                |
|   | R |   |                 |         |      |                |
|   | S |   |                 |         |      |                |
|   | T |   |                 |         |      |                |

## **NON-PATENT DOCUMENTS**

| * |   | Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)   |
|---|---|---|
| * | U | Chiu, H.T., et al.; Metal-Organic CVD of Tantalum Oxide from tert-Butylimidotris(diethylamido)tantalum and Oxygen. Chemical Vapor Deposition, Vol.6, Issue 5, pp.223-225. October 2000. ABSTRACT AND REFERENCE UNAVAILABLE. |
|   | ٧ |   |
|   | w |   |
|   | x |   |

<sup>\*</sup>A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.